

15997 U.S. PTO  
10/075172

02/13/02

PATENT NUMBER and  
ISSUE DATE.

U.S. UTILITY Patent Application

APPL NUM 10075172	FILING DATE 02/13/2002	CLASS 451	SUBCLASS 56	GAU 3723	EXAMINER <i>hose</i> Ojini
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\*APPLICANTS: Cron Brian;

ABANDONED

\*\*CONTINUING DATA VERIFIED:

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\*\* FOREIGN APPLICATIONS VERIFIED:

PG-PUB DO NOT PUBLISH ☐

RESCIND ☐

Foreign priority claimed

☐ yes ☒ no

35 USC 119 conditions met

☐ yes ☒ no

Verified and Acknowledged Examiners's initials *AD*

ATTORNEY DOCKET NO

MI22-1804

TITLE : Methods for conditioning surfaces of polishing pads after chemical-mechanical polishing, and apparatuses for conditioning surfaces of polishing pads

U.S. DEPT. OF COMM./PAT. & TM.-PTO-436L (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED	
			Total Claims	Print Claim for O.G.
ISSUE FEE		Primary Examiner	DRAWING	
Amount Due	Date Paid		Sheets Drwg.	Figs. Drwg.
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE	Application Examiner	
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